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PEOPLE'S REPUBLIC OF CHINA

GB/T 15861-1995

Generic specification of ion beam etching system

离子束蚀刻机通用技术条件

(English Translation)

Issued on: December 22, 1995 **Implemented on: August 1, 1996**

Issued by: State Bureau of Technical Supervision

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Table of Contents

Document data

1 Document data

Sector: National standard (Recommended).

Issuing body: State Bureau of Technical Supervision.

Date of issue: 1995-12-22.

Date of implementation: 1996-08-01.

Status: obsolete, replaced by GB/T 15861-2012.

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